INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 11, 2026

IGI Report Number	LG847664856
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	OVAL BRILLIANT
Measurements	8.74 X 5.97 X 3.82 MM

GRADING RESULTS

Carat Weight	1.26 CARAT
Color Grade	F
Clarity Grade	VVS 2

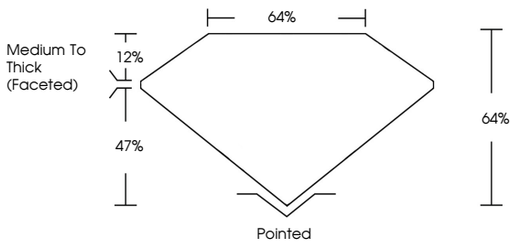
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG847664856

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG847664856
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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Medium To Thick (Faceted) 64% 12% 47% 64% Pointed

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IGI

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Clarity Grade VVS 2
Depth 64%
Table 64%
Girdle Medium To Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
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